

**Notice of References Cited**

Application/Control No.

09/370,508

Applicant(s)/Patent Under  
Reexamination  
SHARMA ET AL.

Examiner

DuyVu n Deo

Art Unit

1765

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**U.S. PATENT DOCUMENTS**

*		Document Number	Date	Name	Classification	
		Country Code-Number-Kind Code	MM-YYYY			
	A	US-				
	B	US-				
	C	US-				
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Wolf et al; Silicon Processing for the VLSI Era; Vol. 1; 1986; pg 5 429-455, 518.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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